

## INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

Docket Number (Optional)

13437 US

Application Number

10/644,377

Applicant(s)

Wieland et al.

Filing Date

August 20, m 2003

Group Art Unit

1754  
To be assigned

## U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
WAL		4,415,484	11/15/83	Setzer et al.			04/26/82
WAL		5,177,041	01/05/93	Horiuchi et al.			06/20/91
WAL		5,459,119	10/17/95	Abe et al.			02/07/94
WAL		6,436,363 B1	08/20/02	Hwang et al.			08/31/00
WAL		US2002/0007595 A1	01/24/02	Maier-Roeltgen et al.			08/27/01
WAL		US 2001/00161188 A1	08/23/01	Haga et al.			12/13/00
WAL		US 2002/0009408A1	01/24/02	Wieland et al.			05/14/01

## FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
WAL		WO 02/18269	03/07/02	WIPO				
WAL		EP 0462 593 A1	12/27/91	EP				
WAL		DE 100 62 662 A1	07/05/01	German				
WAL		WO 99/48805	09/30/99	WIPO				
WAL		WO 99/33567	07/08/99	WIPO				

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

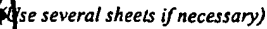

EXAMINER

Wayne A. Fargel

DATE CONSIDERED

8 9-1-05

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.



1754 assigned